Electronic Acknowledgement Receipt				
EFS ID:	1114079			
Application Number:	10710653			
Confirmation Number:	4652			
Title of Invention:	PRESSURE ASSISTED WAFER HOLDING APPARATUS AND CONTROL METHOD			
First Named Inventor:	David J. Bain			
Customer Number:	29371			
Filer:	Sean Sullivan/Jessica Huston			
Filer Authorized By:	Sean Sullivan			
Attorney Docket Number:	FIS920040119US1			
Receipt Date:	14-JUL-2006			
Filing Date:	27-JUL-2004			
Time Stamp:	16:54:58			
Application Type:	Utility			
International Application Number:				
Dovment information.	•			

## Payment information:

Submitted with Payment	no
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## File Listing:

Document Number	Document Description	File Name	File Size(Bytes)	Multi Part	Pages
1		7-14-06_amendment.pdf	981788	yes	11

	Multipart Description			
	Doc Desc	Start	End	
	Transmittal letter	1	1	
	Amendment - After Non-Final Rejection	2	11	
Warnings:		•		

Information:

Total Files Size (in bytes): 981788

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## New Applications Under 35 U.S.C. 111

If a new application is being filed and the application includes the necessary components for a filing date (see 37 CFR 1.53(b)-(d) and MPEP 506), a Filing Receipt (37 CFR 1.54) will be issued in due course and the date shown on this Acknowledgement Receipt will establish the filing date of the application.

## National Stage of an International Application under 35 U.S.C. 371

If a timely submission to enter the national stage of an international application is compliant with the conditions of 35 U.S.C. 371 and other applicable requirements a Form PCT/DO/EO/903 indicating acceptance of the application as a national stage submission under 35 U.S.C. 371 will be issued in addition to the Filing Receipt, in due course.